



Ultra Precision Technologies for Micromachining

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Deadline for manuscript
submissions:

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Message from the Guest Editors

Micromachining is a group of advanced technologies that enables microcomponents and/or microstructures to be fabricated with at least one dimension lying in the microscale. It has long been recognized as a powerful tool for high-value manufacturing and has been widely applied across different industrial sectors. Ultraprecision technologies, which are the main thrust of this step-change. They bring significant advantages to micromachining from the aspects of high accuracy and resolution, high complexity, high throughput, low lead time, low investment cost, etc.

In this Special Issue, we seek papers in all kinds of ultraprecision technologies with a clear contribution to the advancement of micromachining. Micromachining technologies include but are not limited to mechanical-based technologies such as diamond turning, precision grinding; chemical based technologies such as photolithography, reactive ion etching; physical based technologies such as laser, ion beam, electrical discharge machining; and their hybrids. Original research papers, review articles, and short communications are all welcome.





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Message from the Editor-in-Chief

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